Electronic Acknowledgement Receipt					
EFS ID:	5175368				
Application Number:	10544783				
International Application Number:					
Confirmation Number:	5339				
Title of Invention:	Method for forming nickel silicide film, method for manufacturing semiconductor device, and method for etching nickel silicide				
First Named Inventor/Applicant Name:	Koichi Terashima				
Customer Number:	23373				
Filer:	Michael Gregory Raucci/Kelley Lipphard				
Filer Authorized By:	Michael Gregory Raucci				
Attorney Docket Number:	Q89627				
Receipt Date:	17-APR-2009				
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Application Type:	U.S. National Stage under 35 USC 371				
Payment information:					

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$130
RAM confirmation Number	2131
Deposit Account	194880
Authorized User	

File Listing:

Document	Document Description	File Name	File Size(Bytes)/	Multi	Pages
Number			Message Digest	Part /.zip	(if appl.)

1	Q89627_Response.PDF	186329	yes	5					
		Q03027_Nesponse.i Di	ca75221cc8b53bf598b6fd05cea094a03f7d 56da	yes	J				
	Multipart Description/PDF files in .zip description								
	Document Description		Start	End					
	Amendment After Final		1	1					
	Applicant Arguments/Remarks Made in an Amendment		2	4					
	Extension of Time		5	5					
Warnings:									
Information:									
2 Fee Worksheet (PTO-06)	fee-info.pdf	30177	no	2					
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Warnings:		•		•					
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		Total Files Size (in bytes): 21	6506					

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.